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U.S.S.N. 10,656,986

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lu et al.

Group Art Unit: 2813

Serial No.: 10,656,986

Examiner: Doty, H.A.

Filed: 09/04/2003

In Response to Office Action

Dated: 06/09/2005

For: **MULTIPLE EXPOSURE METHOD FOR FORMING
PATTERNED PHOTORESIST LAYER**

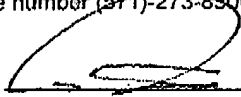
Attorney Docket No.: 67,200-1145

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Randy W. Tung

Printed Name


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**Please forward all correspondence to
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U.S.S.N. 10,656,986

RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 06/09/2005,
please enter the following amendments and consider the following
remarks.

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